



Attorney Docket # 5367-47RCE2

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stefan BADER et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: Method for Depositing a Material on a
Substrate Wafer

Examiner: RAO, G. Nagesh
Group Art: 1722

I hereby certify that this correspondence is being
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Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on
October 22, 2007
(Date of Deposit)

Lance J. Lieberman
Name of applicant, assignee or Registered Representative

Signature

October 22, 2007
Date of Signature

PETITION FOR EXTENSION OF TIME UNDER 37 C.F. R. § 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

- [x] This is the first request for an extension of time relative to the outstanding paper. Please grant a one-month extension of time. Payment for the extension fee of \$120 is included with the RCE filing fee. With this extension, the deadline for filing the required paper will be extended to October 21, 2007 (Sunday).
- [X] Please charge any additional fees, or credit any overpayment, to Deposit Account No. 03-2412. A duplicate copy of this sheet is enclosed.

Respectfully submitted,
COHEN PONTANI LIEBERMAN & PAVANE LLP

By

Lance J. Lieberman
Reg. No. 28,437
551 Fifth Avenue, Suite 1210
New York, New York 10176
(212) 687-2770

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